	Application No.	Applicant(s)
Notice of Allowability	10/722,275	SON ET AL.
	Examiner	Art Unit
	Jack Chen	2813
The MAILING DATE of this communication apperation allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	ears on the cover sheet with the co (OR REMAINS) CLOSED in this ap or other appropriate communicatio GHTS. This application is subject to	correspondence address oplication. If not included n will be mailed in due course. THIS
1. This communication is responsive to		
2. The allowed claim(s) is/are <u>1-10</u> .		
3. The drawings filed on <u>25 November 2003</u> are accepted by the Examiner.		
<ul> <li>4.  Acknowledgment is made of a claim for foreign priority una)  All b)  Some* c)  None of the:</li> <li>1.  Certified copies of the priority documents have</li> <li>2.  Certified copies of the priority documents have</li> <li>3.  Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)).</li> <li>* Certified copies not received:</li> </ul>	been received. been received in Application No	
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		complying with the requirements
5. A SUBSTITUTE OATH OR DECLARATION must be submit INFORMAL PATENT APPLICATION (PTO-152) which give		
6. CORRECTED DRAWINGS (as "replacement sheets") mus  (a) including changes required by the Notice of Draftspers  1) hereto or 2) to Paper No./Mail Date  (b) including changes required by the attached Examiner's Paper No./Mail Date  Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the	on's Patent Drawing Review (PTO s Amendment / Comment or in the ( 84(c)) should be written on the draw	Office action of ings in the front (not the back) of
7. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT I		
Attachment(s)  1. ☑ Notice of References Cited (PTO-892)  2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)  3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date	6. ☑ Interview Summary Paper No./Mail Da 8), 7. ☑ Examiner's Amend	ate <u>9/27/04</u> .
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## **DETAILED ACTION**

In response to the communication filed on November 25, 2003, claims 1-10 are active in this application.

# Priority

1. Receipt is acknowledged of papers submitted under 35 U.S.C. 119(a)-(d), which papers have been placed of record in the file.

#### Oath/Declaration

Oath/Declaration filed on November 25, 2003 has been considered.

### **EXAMINER'S AMENDMENT**

2. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Richard J. Streit on September 24, 2004.

The application has been amended as follows:

Re claim 6, line 1, change "the power" to –wherein the power of the third deposition conditions--.

Re claim 8, page 14, line 2, insert -of the first deposition conditions—after "interval".

Art Unit: 2813

Re claim 8, page 15, line 1, insert -of the first deposition conditions—after "pressure".

Re claim 9, line 2, insert -of the first deposition conditions—after "interval".

Re claim 9, line 3, insert -of the first deposition conditions—after "pressure".

Re claim 10, line 1, insert -of the third deposition conditions—after "power".

## Reasons For Allowance

- 3. Claims 1-10 are allowable over the prior art of record.
- 4. The following is an examiner's statement of reasons for allowance: the prior art of record neither teach nor make obvious the claimed limitation of the instant application as a whole as recited in claims 1 and 7, respectively. In particular, the prior art does not teach or suggest relieving the stress and preventing the bending of the insulating substrate of a TFT by successively forming first and second insulating films on the insulating substrate including the gate electrode, the first insulating film being formed under first deposition conditions including power, pressure and electrode interval, the second insulating film being formed under second deposition conditions where at least one of the first deposition conditions is changed *continuously* over time.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Application/Control Number: 10/722,275

Art Unit: 2813

## Conclusion

Page 4

3. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. Kim, U.S./6,589,825 B2 and Nakahori et al., U.S./6,399,428 B2 teach the similar methods for forming the device.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Jack Chen whose telephone number is (571)272-1689. The examiner can normally be reached on Monday-Friday (9:00am-6:30pm) alternate Monday off.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Carl W Whitehead can be reached on (571)272-1702. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Jack Chen

Primary Examiner

Art Unit 2813

Towers